



PATENT
81788.0020

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Shota Kitamura, et al.

Serial No: 09/392,865

Filed: September 9, 1999

For: NON-VOLATILE SEMICONDUCTOR
MEMORY DEVICE AND ITS
MANUFACTURING METHOD

Art Unit: 2811

Examiner: T. Tran

#13/Frt. of
Time (3)
R. Tyson
1/23/01

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: BOX AF, Assistant Commissioner for Patents, Washington D.C. 20231, on

January 5, 2001

Date of Deposit

William H. Wright

Name

Signature

1/5/01
Date

PETITION FOR EXTENSION OF TIME

Box AF

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a three-month extension of time extending to January 5, 2001, the period for response to the final Office Action dated July 5, 2000. A check for \$890 is enclosed. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: January 5, 2001

By:

William H. Wright

Registration No. 36,312

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